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# Classification and Key Feature Extraction for Equipment Health Monitoring

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# Outline

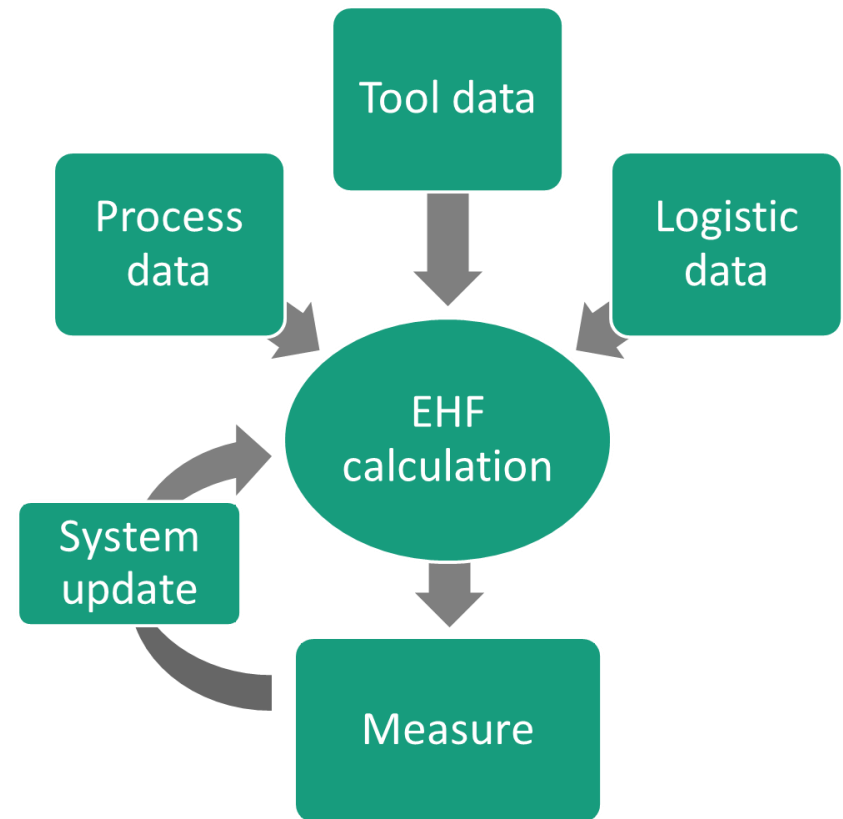
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- I. Motivation
- II. Classification
- III. Key feature extraction
- IV. Application examples
- V. Next steps
- VI. Conclusion

# I. Motivation

**Definition:** Equipment health factor

- Key indicator for monitoring of equipment state
- Based on process/tool, logistic and metrology data
- Utilization of historical data for training of EHF system
- Related key words
  - Equipment health monitoring
  - Equipment fingerprinting
  - Health index
  - EHF



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# Goal of the EHF application is to enable...

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- **Dynamic Sampling**

Sampling rate is flexible and adjusted to the machine state.

- **Material flow of critical products**

The production of critical products (important customers lots, urgent jobs, etc.) is planned only on machines which have a good system state.

- **Predictive Maintenance (PdM) based on condition monitoring**

The PdM offers cost savings over time-based preventive maintenance, because maintenance actions are performed only when necessary.

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# Instance for EHF application

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- Good machine state – EHF is high
  - ➔ Lower lot sampling rate, important lots will preferably be scheduled to run on this machine
- Machine state not ideal – EHF decreases
  - ➔ More frequent lot sampling, important lots might be scheduled to run on another tool
- “bad” machine state – EHF drops below certain limit
  - ➔ Schedule maintenance

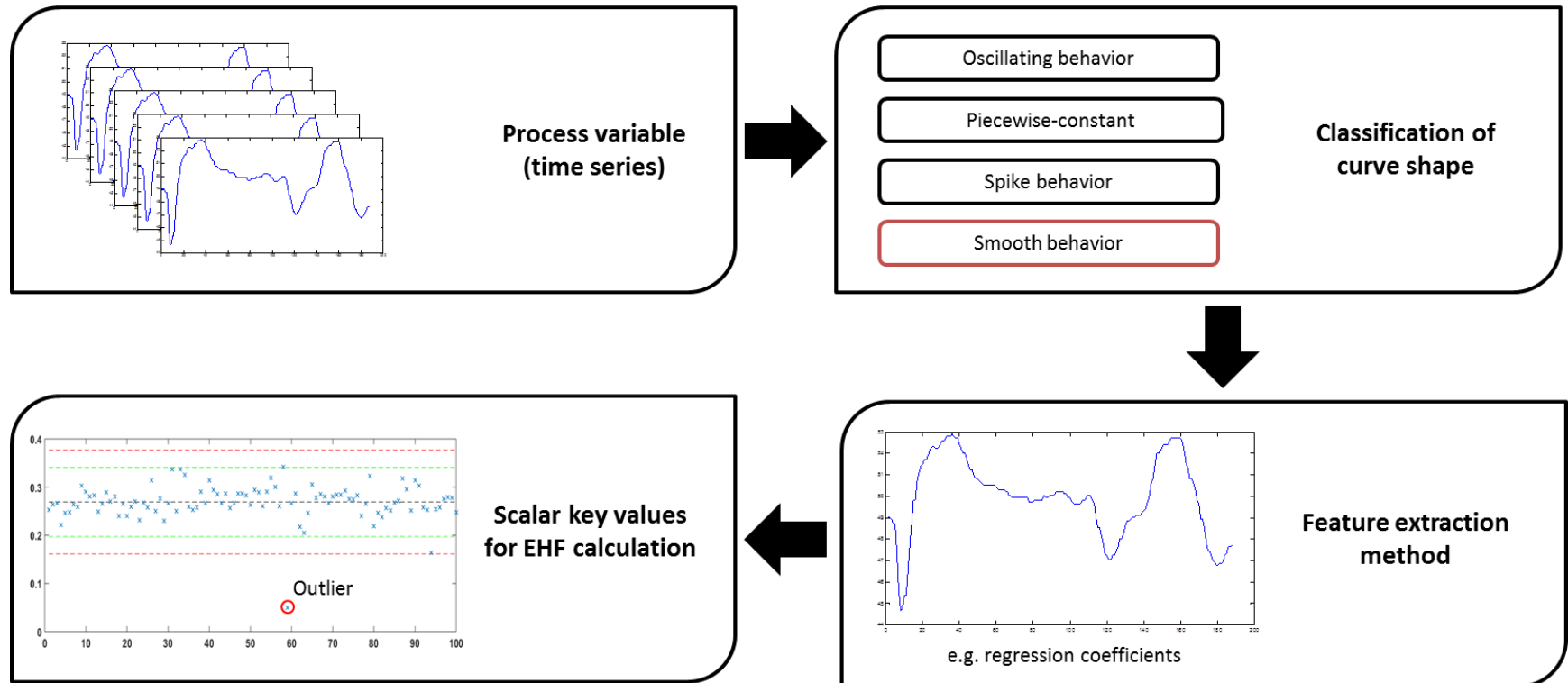
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# Related work

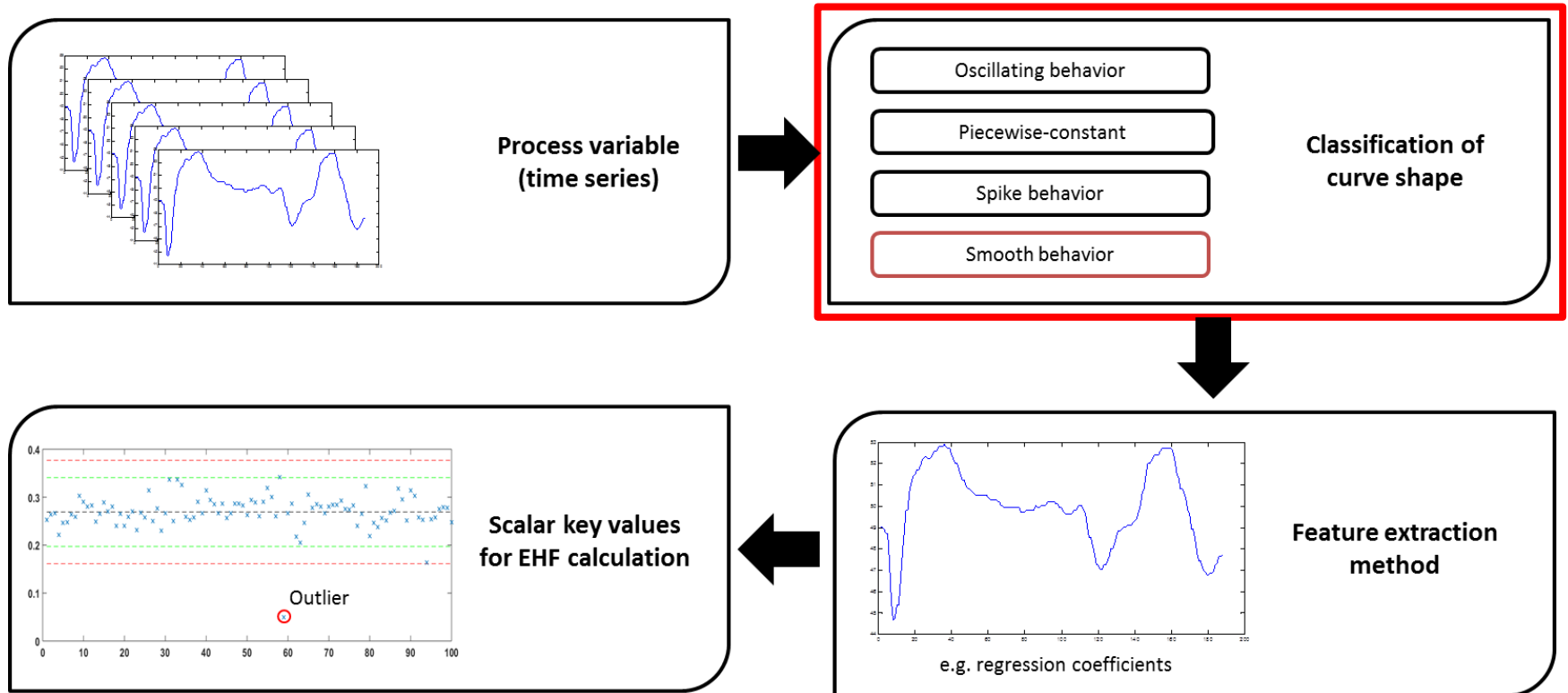
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- Utilization of sensors for simple measurement of wear
- Detection of failures based on key indicators
- Usually only implemented for specific failure classes
- No general method for detection of unknown failures
  
- **Our objective:**
  - Improved preprocessing method to find unknown failures
  - Use of various feature extraction methods dependent on curve shape
  - Generic concept transferable to other processes

# Our approach for EHM



# II. Classification

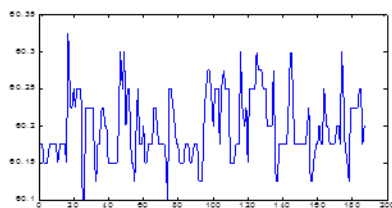




# Defined variable types

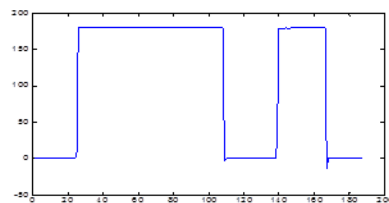
- **Oscillating behavior:** trajectories with periodical variation around a central value
- **Piecewise-constant:** rectangular shaped pulses
- **Spike behavior:** most data points are close to zero with occasional peaks
- **Smooth behavior:** data with little change in its point to point value, the derivation showing only small differences in the gradient

Oscillating behavior



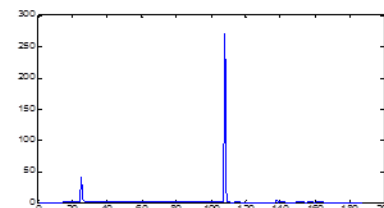
e.g. chamber temperature

Piecewise-constant



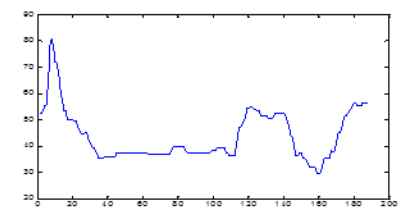
e.g. gas flows

Spike behavior



e.g. reflected RF power

Smooth behavior



e.g. ESC temperature values

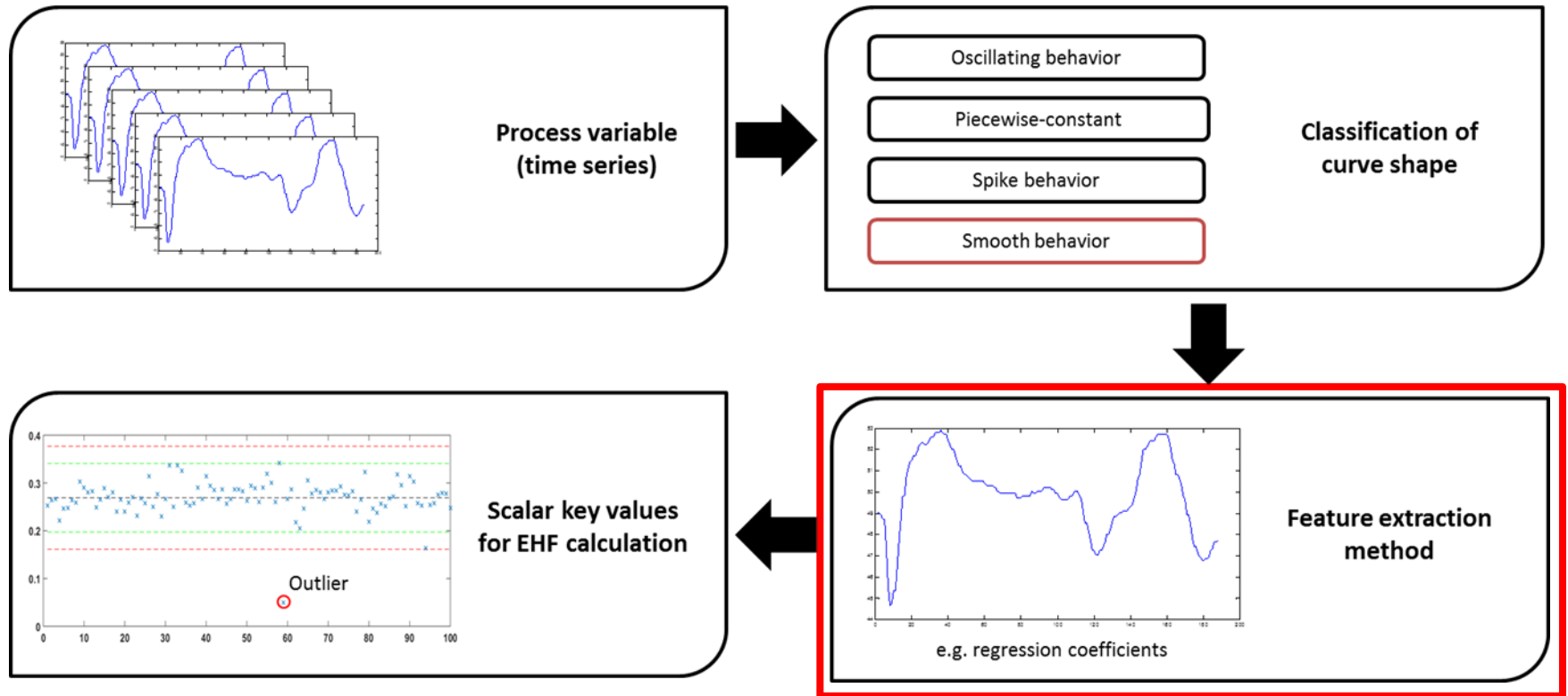
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# Classification through cubic Support Vector Machine

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- Create a training data set containing assignment of variable types
- Cubic support vector machine (SVM) was used
- As predictors were chosen:
  - Kurtosis
  - Crest factor
  - Mean difference of normalized derivation
  - Standard deviation of normalized time series
  - Standard deviation of normalized derivation
  - Logical factor for invariant time series (1 for invariant behavior and 0 for other behavior)

# III. Feature Extraction



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# Types of feature extraction

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- **Simple key features**
  - Mean, median, standard deviation and range
- **Structural features**
  - Descriptive statistics of trajectories
- **Dynamic time warping**
  - Euclidean-distance-based similarity measurement technique
- **Frequency and time-frequency analysis**
  - Analysis in frequency domain instead time domain
- **Statistical analytical methods**
  - e.g. regression coefficients or residual analysis

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# Issues with preprocessing using simple key features

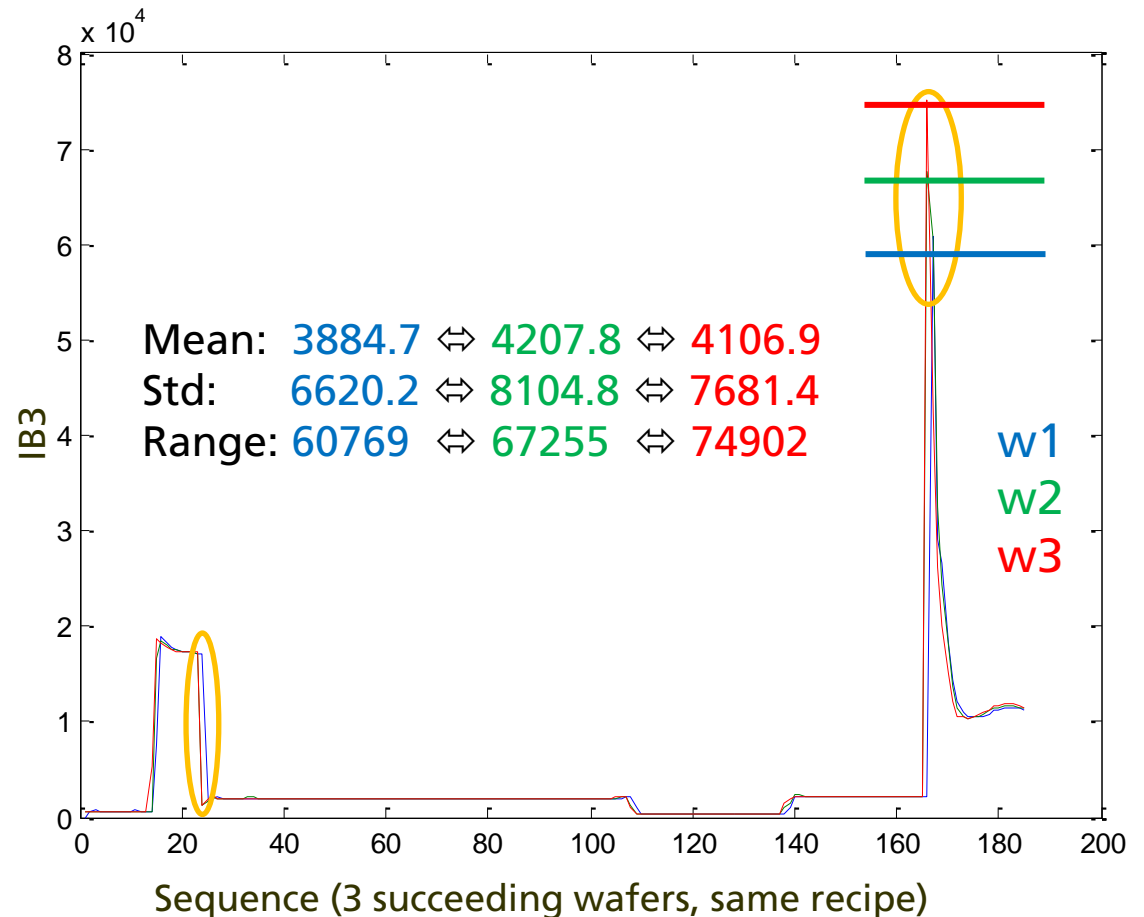
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- Over-/undershooting controllers and length of a signal can have big impact on simple key values
- Potential impact of limited data sampling frequency on true transient behavior
- Measurements from etch processes are non-stationary due to:
  - Aging of the etcher after cleaning cycles as residue accumulates on the inside of the chamber
  - Difference in the incoming materials due to changes in upstream processes
  - Drift in process-monitoring sensors themselves

# Example for simple key features

## Correlation matrix:

	w1	w2	w3
w1	1	-	-
w2	0.7871	1	-
w3	0.6831	0.9802	1



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# Potential feature extraction methods

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## Oscillating behavior

- Frequency analysis
- Time-frequency analysis
- Coefficients from time series modeling

## Piecewise-constant

- Structural features
- Integration
- Regression coefficients

## Spike behavior

- Peak detection
- Structural features
- Integral value of peak

## Smooth behavior

- Regression coefficients
- Residual analysis
- Coefficients from time series modeling

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# Extracted features

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## Oscillating behavior

- Periodicity
- Trend
- Simple key features

## Piecewise-constant

- Number of pulses
- Amount of Under-/Overshoots
- Maximum Overshoot
- Surface area of pulse

## Spike behavior

- Number of peaks
- Peak width
- Surface area of peak
- Distance of peaks

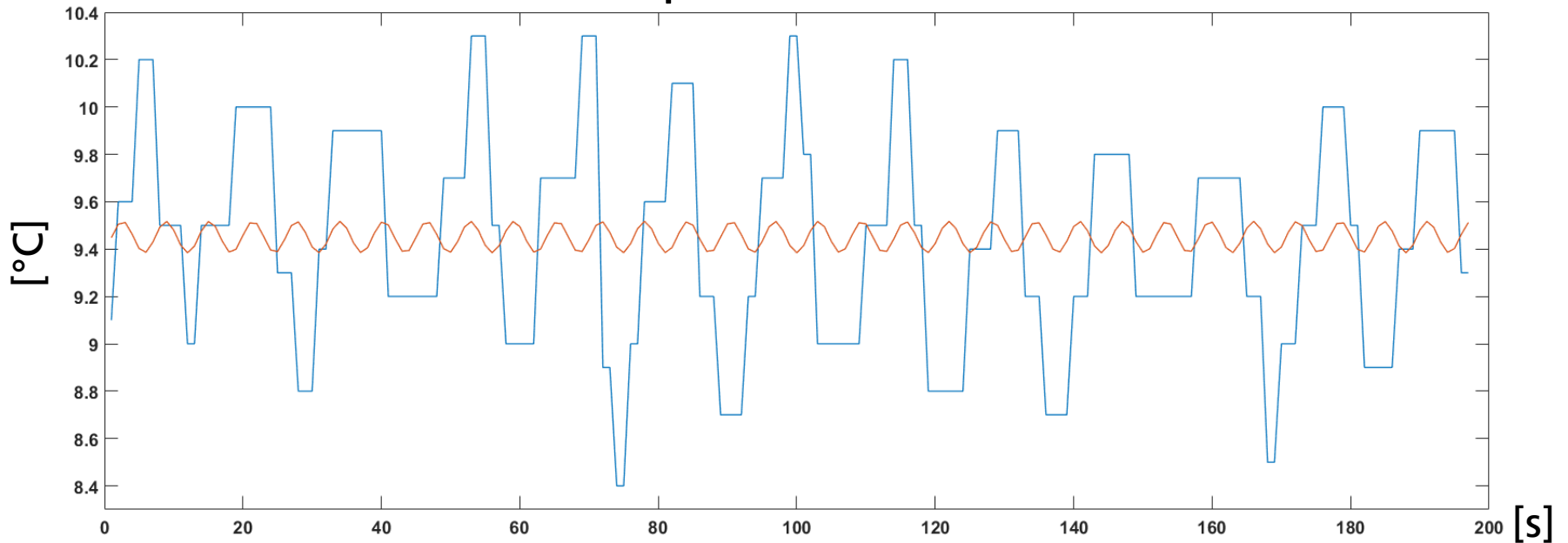
## Smooth behavior

- Wavelet-based correlation coefficient
- RMS of residue
- Surface area



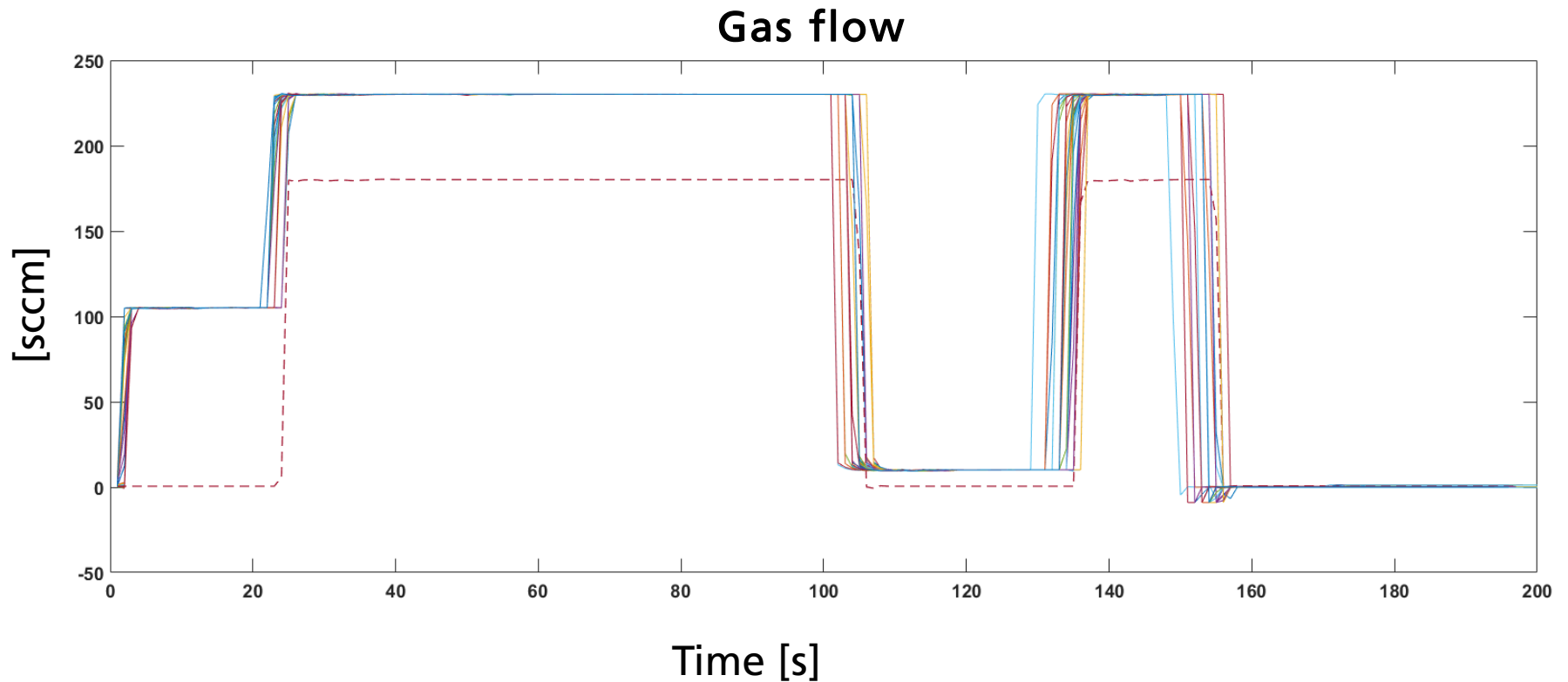
# IV. Application example 1

## Temperature chiller



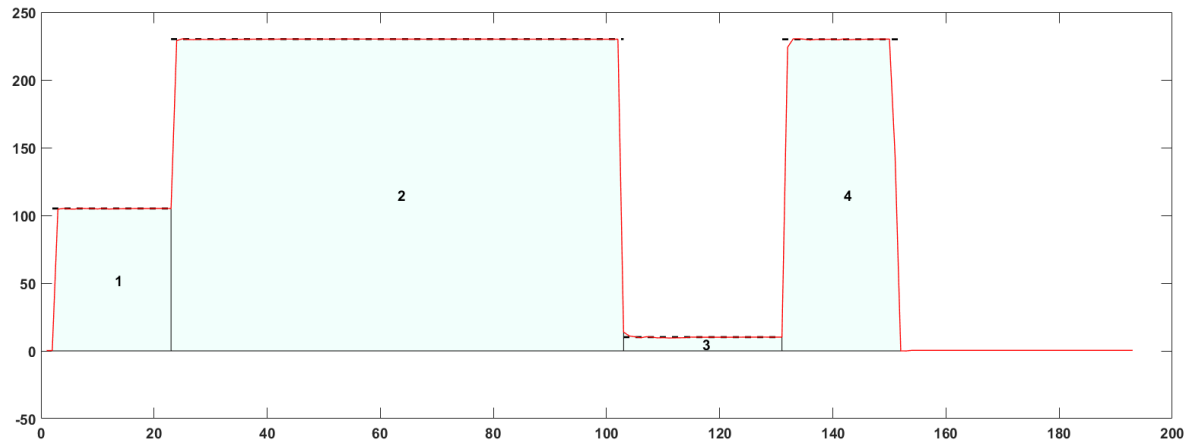
Curve	Mean	Periodicity	Range
Blue	9.4508	15.4763	1.9
Orange	9.4511	6.2733	0.1329

# IV. Application example 2 (1/3)

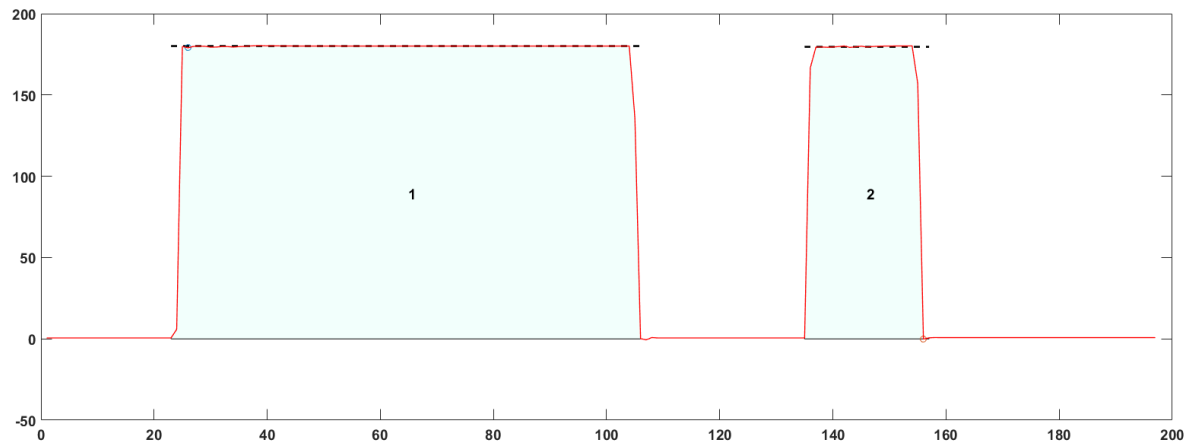


# IV. Application example 2 (2/3)

## Comparison of two Cl<sub>2</sub> Flows



Desired trajectory

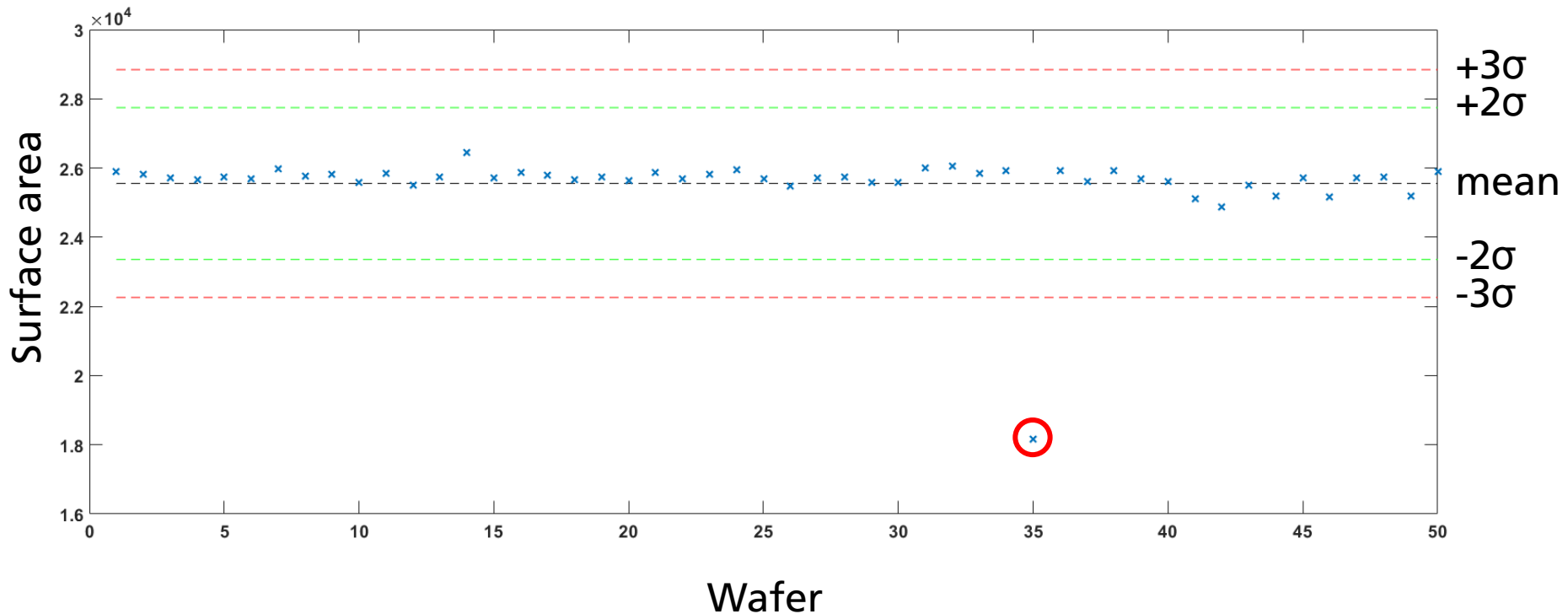


Faulty trajectory

# IV. Application example 2 (3/3)

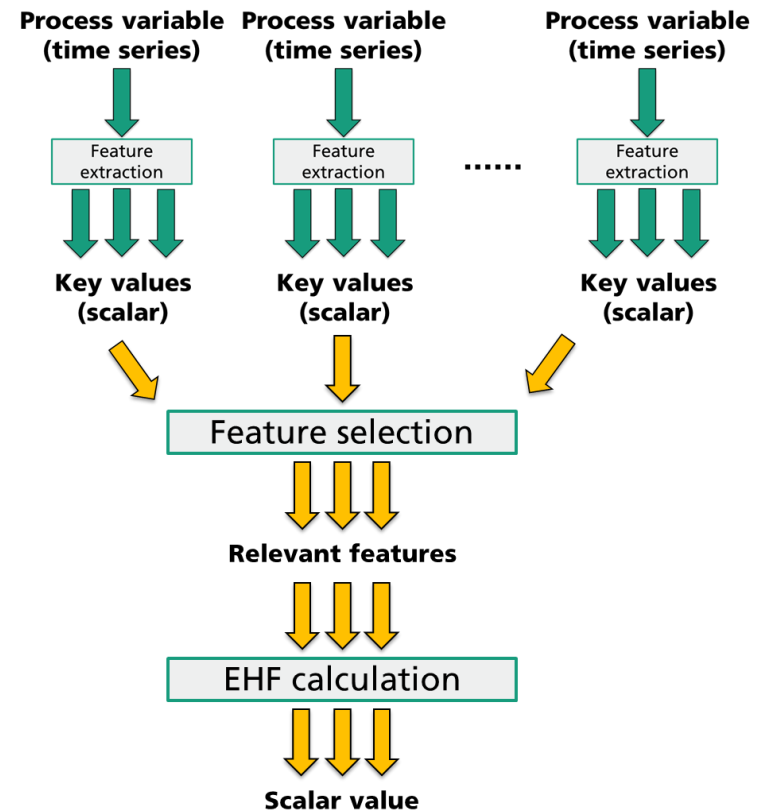
## SPC-Chart: Surface Area

× Key feature values      ○ Outlier



# V. Next steps for EHF calculation

- Feature selection
  - Which features are important for EHF?
  - How to select them automatically?
- EHF Calculation
  - How to combine the relevant key features to a scalar value to express the system state?



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# VI. Conclusion

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- A general method for detection of unknown failures was developed
- Generic concept transferable to other processes
- Application of various feature extraction methods dependent on curve shape
- Extracted key features can be used for EHF calculation or other technologies to improve models, e.g. PCA
- Desired benefit of EHF
  - Lower production costs
  - To support Predictive Maintenance
  - Maintaining high yield

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# Acknowledgment

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  - Infineon Technologies Austria AG
  - Infineon Technologies Dresden GmbH
  - Fraunhofer Institute for Integrated Systems and Device Technology
  - SpeedUp Consulting

**Thank you for listening!**